

Notice of References Cited

Application/Control No.

10/593,297

Applicant(s)/Patent Under
Reexamination
HAN ET AL.

Examiner

HARRY LIU

Art Unit

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,101,176 A	08-2000	Honkasalo et al.	370/335
*	B	US-6,501,955 B1	12-2002	Durrant et al.	455/456.1
*	C	US-2003/0008669 A1	01-2003	Stein et al.	455/456
*	D	US-2003/0054813 A1	03-2003	Riley et al.	455/424
*	E	US-2003/0125045 A1	07-2003	Riley et al.	455/456
*	F	US-6,665,539 B2	12-2003	Sih et al.	455/456.3
*	G	US-2004/0121774 A1	06-2004	Rajkotia et al.	455/441
*	H	US-2004/0165657 A1	08-2004	Simic et al.	375/211
*	I	US-2004/0219930 A1	11-2004	Lin, Ie-Hong	455/456.1
*	J	US-7,039,418 B2	05-2006	Amerga et al.	455/456.1
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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